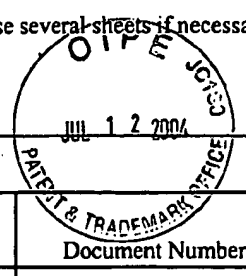


APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 09/900,613		OFGS File No. P/3241-18	
		Applicant Masamichi Fujiwara et al.			
		Filing Date July 6, 2001		Group Art Unit 2874	



U.S. PATENT DOCUMENTS						
Examiner Initial	Document Number	Date MM-YYYY	Name	U.S. Class	U.S. Sub-class	Filing Date If Appropriate
<i>ADD</i>	US-5,074,631	12-1991	Hamano et al.	385	3	
<i>ADD</i>	US-5,566,381	10-1996	Korotky	398	147	
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	US-					

FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	INT. Class	INT. Sub-class	Translation	
						Yes	No
<i>ADD</i>	02-269309	11-1990	Japan	G02F	1/035	X (Abstract)	
<i>ADD</i>	04-014010	01-1992	Japan	G02F	1/035	X (Abstract)	
<i>ADD</i>	08-313852	11-1996	Japan	G02F	1/01	X (Abstract)	
<i>ADD</i>	11-103288	04-1999	Japan	H04J	14/00	X	
<i>ADD</i>	2000-19470	01-2000	Japan	G02F	1/01	X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		

Examiner <i>John D. Lee</i>	Date Considered <i>14 OCTOBER 2004</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.